



Atty. Dkt. No. 054270/0122

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Michael Herman Koch et al.
Title: FABRICATION OF ZINC OXIDE FILMS
ON NON-PLANAR SUBSTRATES AND
THE USE THEREOF
Appl. No.: 09/403,505
Filing Date: February 1, 2000
Examiner: Brian K. Talbot
Art Unit: 1762

#12/B
12/23/00
(AB)

AMENDMENT

Commissioner for Patents
Box NON-FEE AMENDMENT
Washington, D.C. 20231

Sir:

In reply to the Office Action dated July 28, 2000, the period for reply extending to November 28, 2000 by virtue of a petition and fee for a one-month extension of time, please amend the application as follows:

In the Claims:

Please amend the claims as follows:

1. (Amended) A method of [manufacture of] manufacturing a substantially continuous circumferential coating on a [non-planer] non-planar substrate, said method comprising: [the step of:]
utilizing a substantially non directional gaseous deposition technique and a substantially static substrate deposition geometry to deposit said coating on said non-planar substrate.

Claim 2, line 2, change "characteritics" to --characteristics--.

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